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CONFIRMATION NO. 6614

<b>SERIAL NUMBER</b> 10/541,279	<b>FILING OR 371(c) DATE</b> 07/01/2005 <b>RULE</b>	<b>CLASS</b> 324	<b>GROUP ART UNIT</b> 2858	<b>ATTORNEY DOCKET NO.</b> 10030242-04	
<b>APPLICANTS</b> Go Tejima, Toyoda-shi, Aichi, JAPAN; Toshiaki Ueno, Kanagawa, JAPAN;  <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/00788 01/28/2004  <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-030511 02/07/2003					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 7	<b>TOTAL CLAIMS</b> 10	<b>INDEPENDENT CLAIMS</b> 4
<b>ADDRESS</b> 27623					
<b>TITLE</b> Apparatus and method for inspecting thin film transistor active matrix substrate					
<b>FILING FEE RECEIVED</b> 1100	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		